



In re Application of

HITOSHI NAKANO

Application No.: 09/536,637

Filed: March 28, 2000

For: APPARATUS WITH AIR-CONDITIONING
SYSTEM, AND DEVICE MANUFACTURING
METHOD USING THE SAME

Docket No.: 684.2985

Examiner: L. Ciric

Group Art Unit: 3743

Date: October 9, 2001

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	19	MINUS	20	= 0	x \$9 \$18	\$ -0-
INDEP. CLAIMS	2	MINUS	3	= 0	x \$42 \$84	\$ -0-
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ -0-

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

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- ☐ A check in the amount of \$____ is enclosed.
- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- ☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant

Registration No. 32,533

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SDM:mm

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Not approved
JVC
12-6-01

L9
10-12-01
#10

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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REQUEST TO MAKE DRAWING CHANGES

Sir:

Enclosed, in accordance with U.S. Patent and Trademark Office Practice, are copies of proposed drawing changes shown in red ink, wherein Figure 1 is amended to include a semiconductor manufacturing equipment, inspection equipment and measuring equipment labelled in rectangular box form.

Approval of the drawing corrections by the Examiner is respectfully requested.

Applicants' undersigned attorney may be reached in our Washington, D.C.
office by telephone at (202) 530-1010. All correspondence should continue to be directed to our
below-listed address.

Respectfully submitted,



Attorney for Applicants

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